

HAUPTSEMINAR

Data Mining And Machine Learning Approaches For Semiconductor Test And Diagnosis

Title: Dimensionality Reduction for Test Optimization

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OUTLINE

Introduction



Methodology



{ PCA
Outlier Removing
Variable Reduction
Classification Criteria

A Special Case: Burn-in Reduction

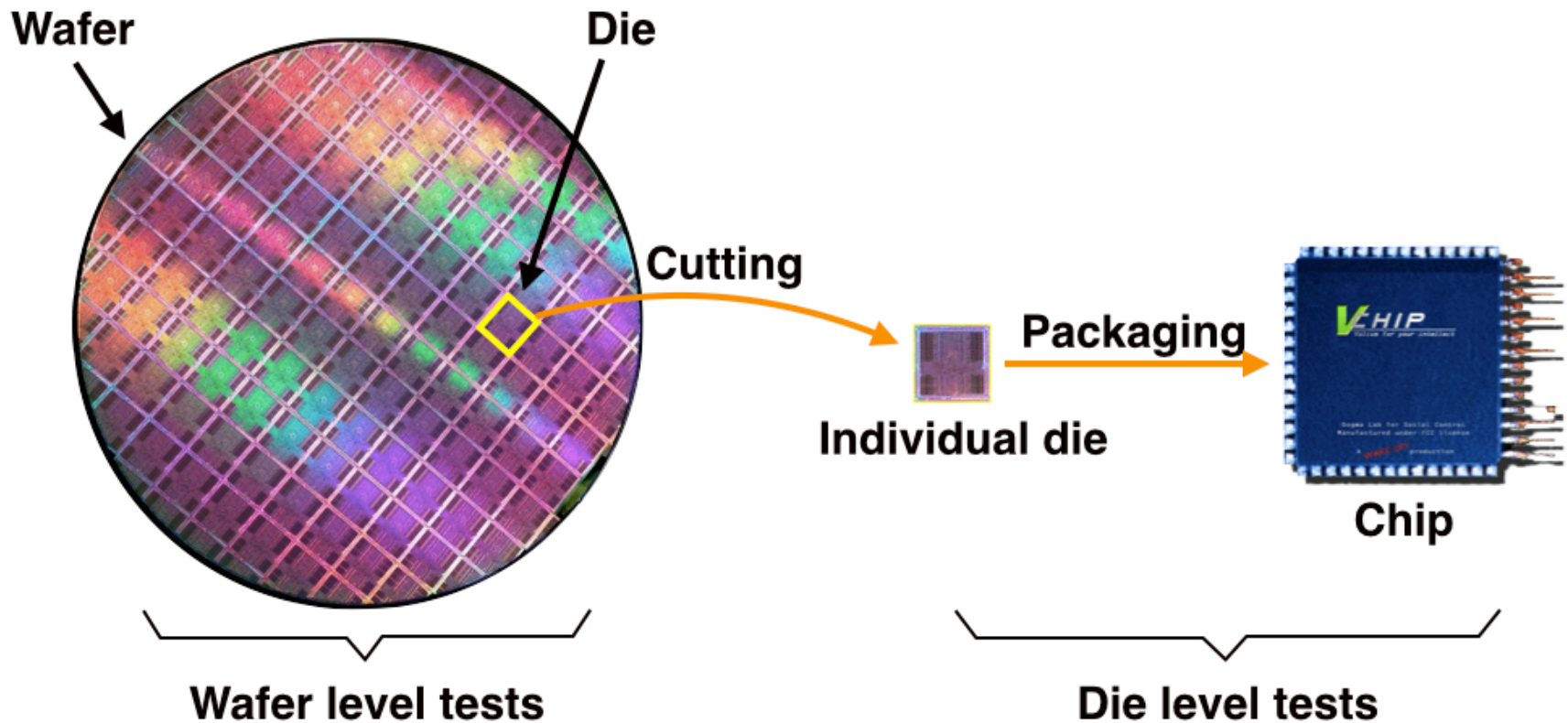


Experiment Analysis



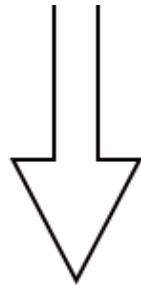
Conclusions

INTRODUCTION: Chip Test



INTRODUCTION: Challenges

High Dimensionality
Costly & Time-Consuming Test



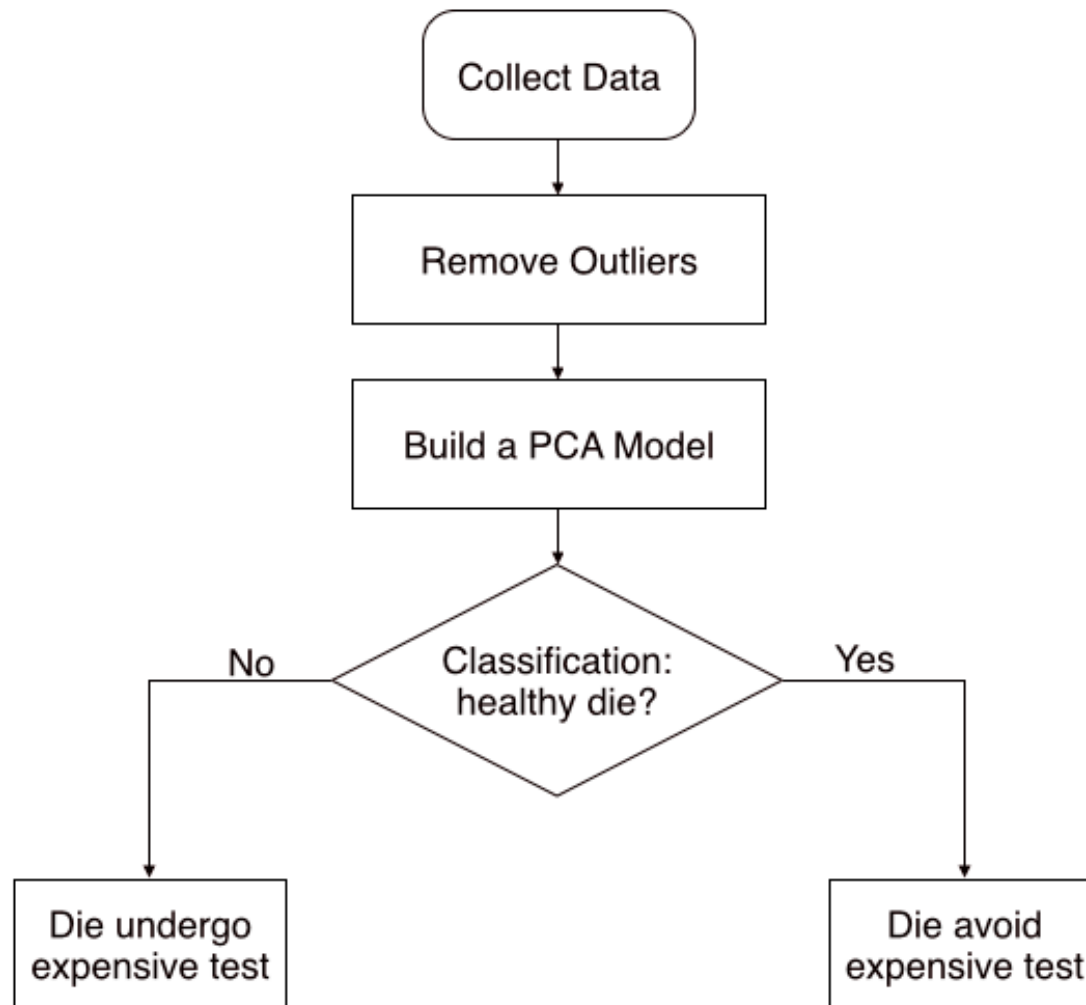
Motivation

Test Optimization:
Dimensionality Reduction
Time & Cost Saving

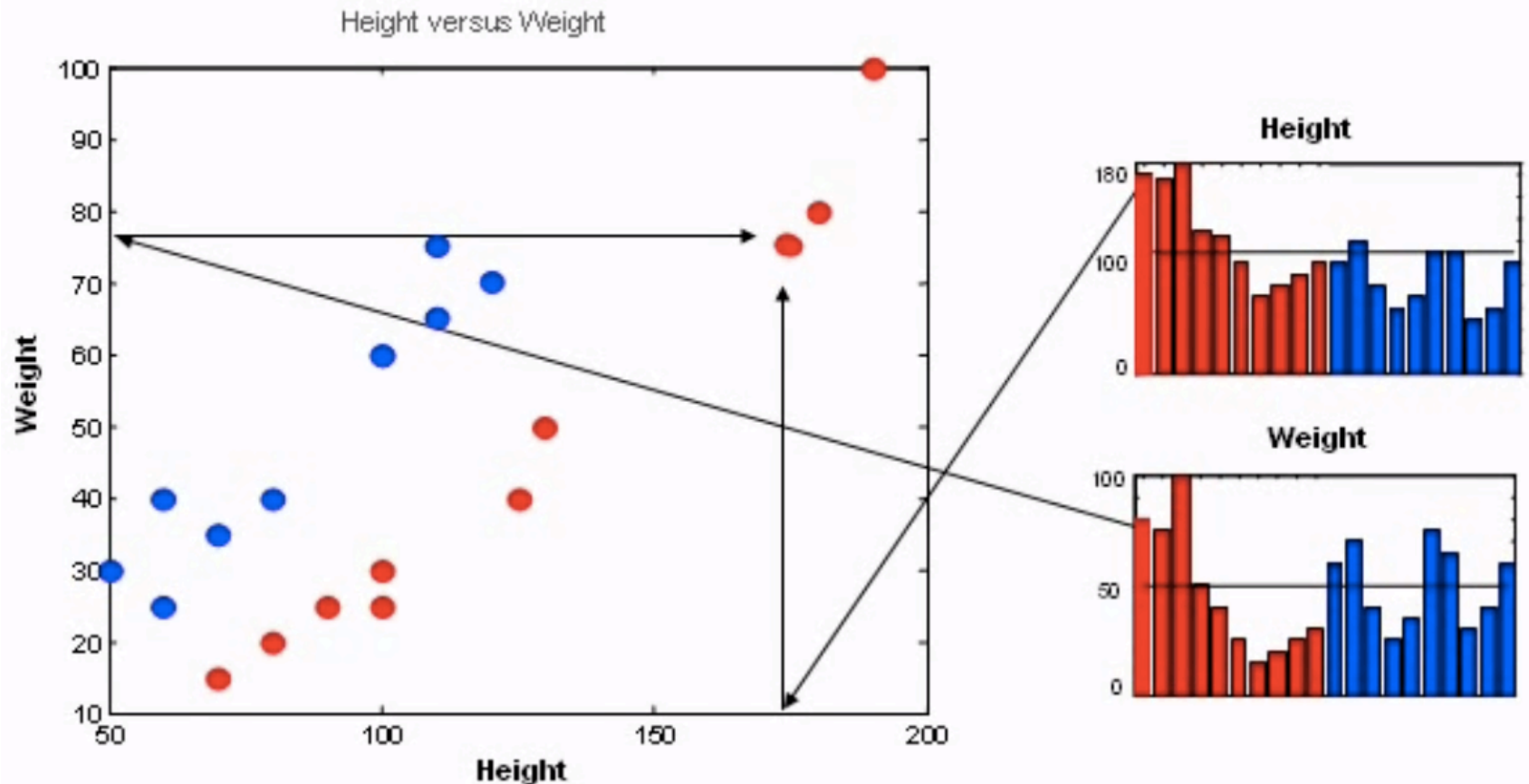


Burn-in Test Machine

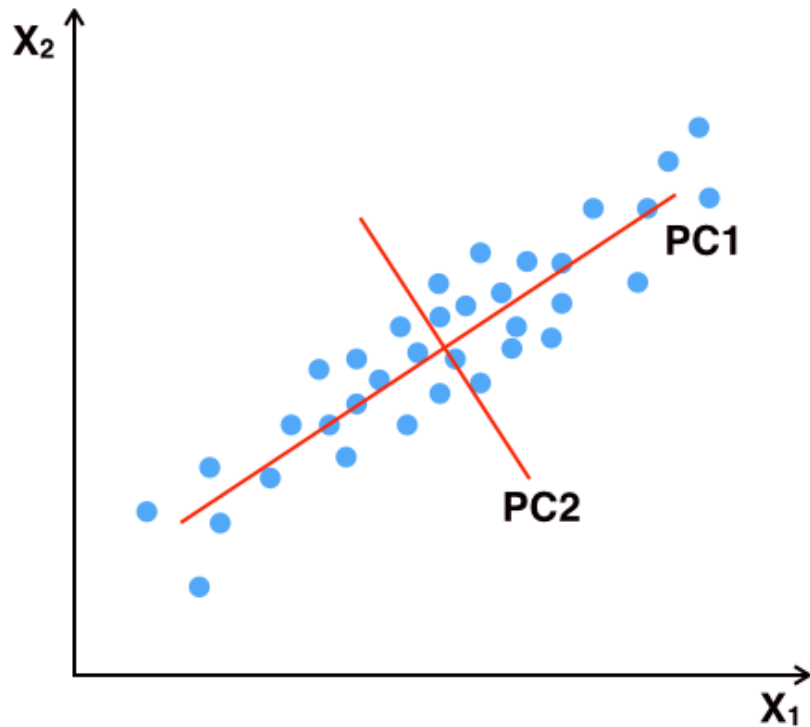
METHODOLOGY OVERVIEW



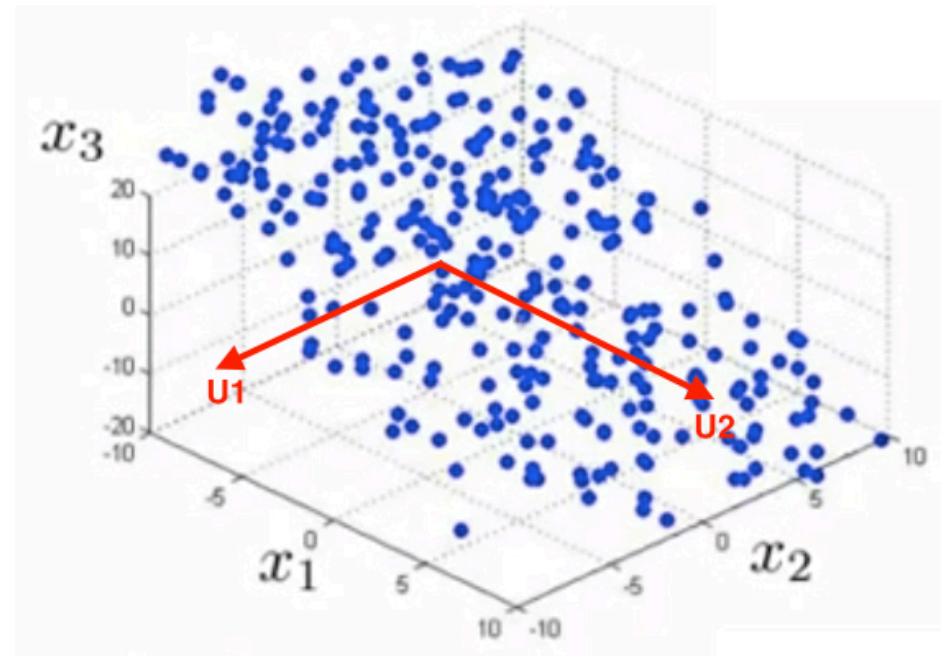
A USEFUL TOOL: PCA



A USEFUL TOOL: PCA



2 D to 2 D



3 D to 2 D

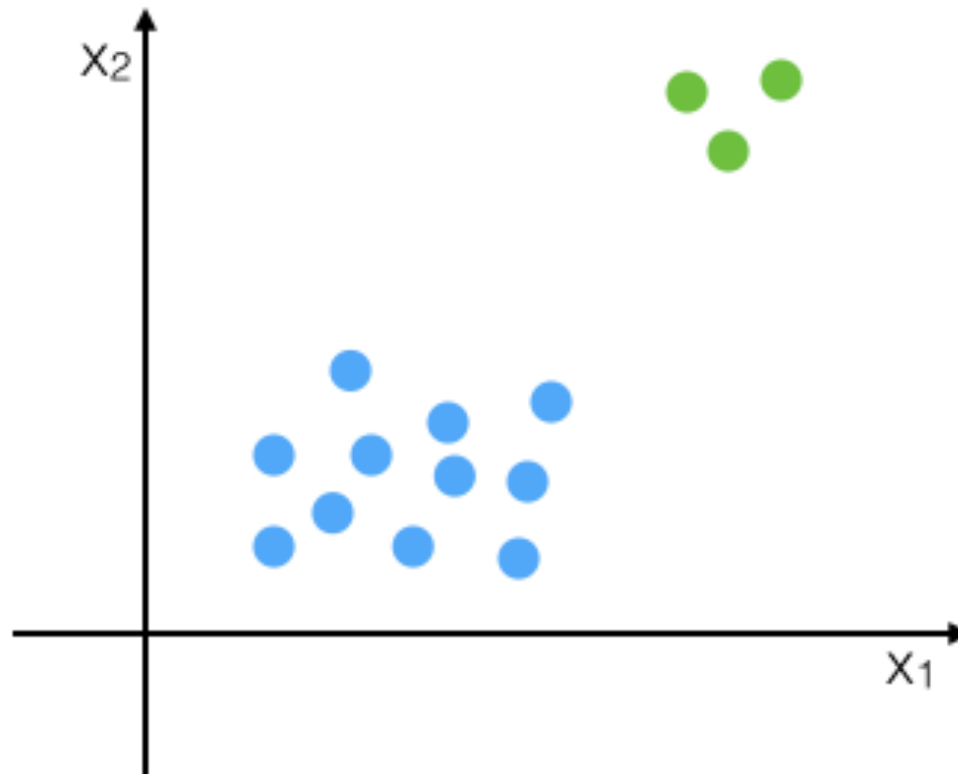
How PCA Works: Finding PCs

$$\begin{aligned} z_1 &= a_{11}x_1 + a_{12}x_2 + \cdots + a_{1n}x_n \\ z_2 &= a_{21}x_1 + a_{22}x_2 + \cdots + a_{2n}x_n \\ &\vdots \\ z_n &= a_{n1}x_1 + a_{n2}x_2 + \cdots + a_{nn}x_n \end{aligned} \quad \begin{pmatrix} Z_1 \\ Z_2 \\ \vdots \\ Z_K \end{pmatrix} = \begin{pmatrix} a_{11} & a_{12} & \cdots & a_{1n} \\ a_{21} & a_{22} & \cdots & a_{2n} \\ \vdots & \vdots & & \vdots \\ a_{n1} & a_{n2} & \cdots & a_{nn} \end{pmatrix} \bullet \begin{pmatrix} x_1 \\ x_2 \\ \vdots \\ x_n \end{pmatrix}$$

Covariance Matrix

$$\begin{pmatrix} \text{Var}(x_1, x_1) & \text{Cov}(x_1, x_2) & \cdots & \text{Cov}(x_1, x_n) \\ \text{Cov}(x_2, x_1) & \text{Var}(x_2, x_2) & \cdots & \text{Cov}(x_2, x_n) \\ \vdots & & & \\ \text{Cov}(x_n, x_1) & \text{Cov}(x_n, x_2) & \cdots & \text{Var}(x_n, x_n) \end{pmatrix}$$

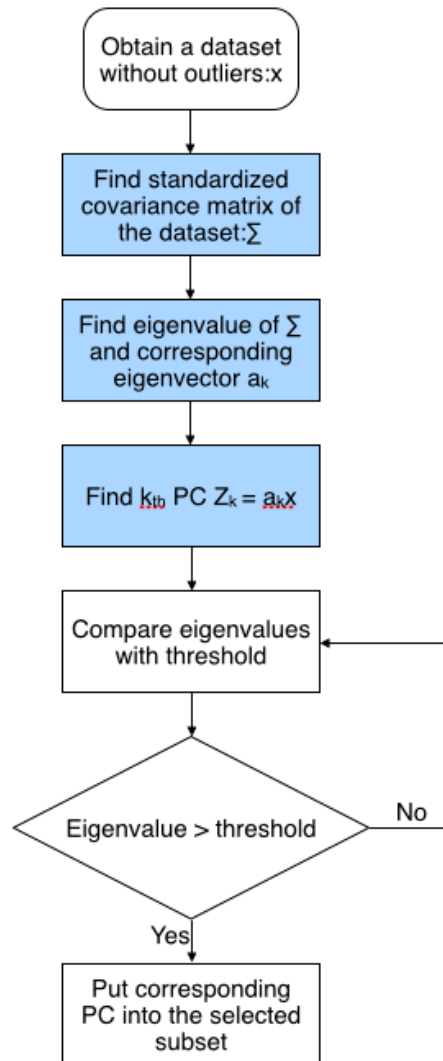
Outlier Removing



Outlier Removing Criteria

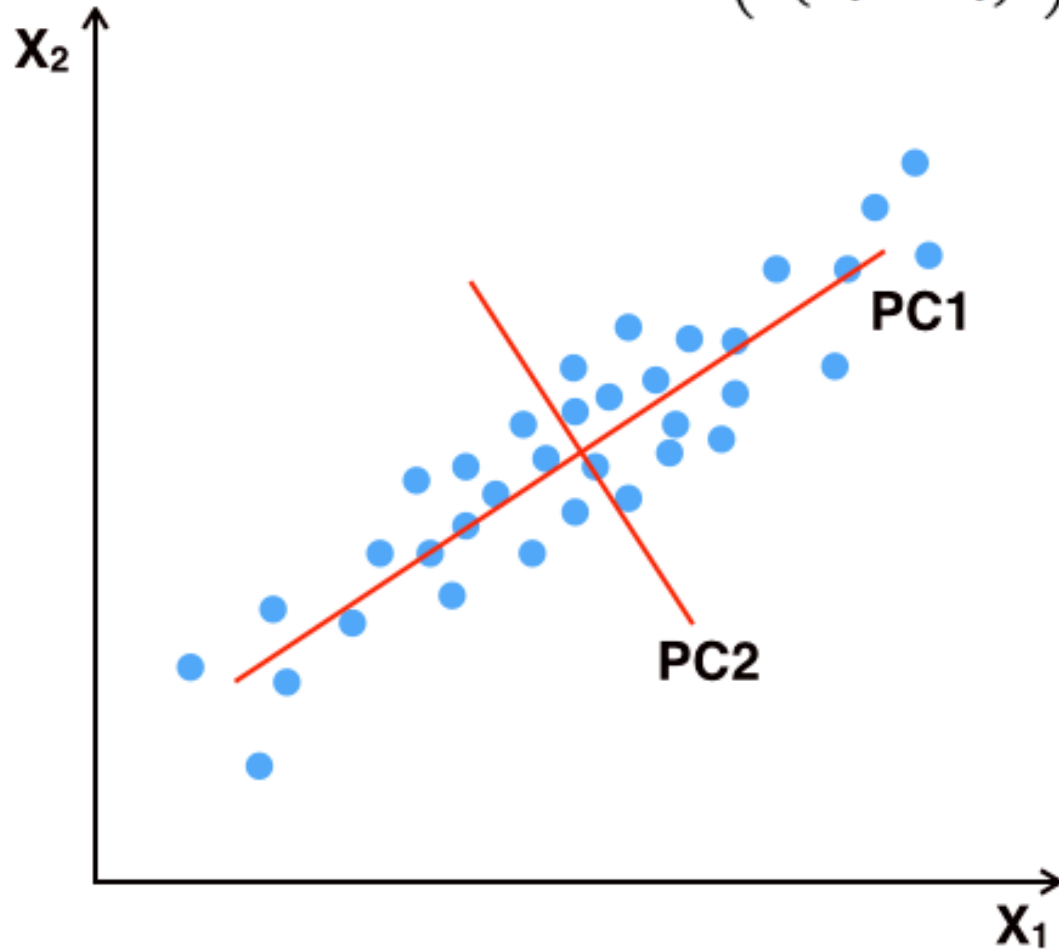
Criterion	Equation	Application Situation
1st	$d_{1i}^2 = \sum_{k=p-q+1}^p z_{ik}^2$	Data whose insignificant PCs have a narrow range of variances.
2nd	$d_{2i}^2 = \sum_{k=p-q+1}^p \frac{z_{ik}^2}{l_k}$	Data whose insignificant PCs have variances that are appreciable compared to the excursions caused by defects, and cover a wide range.
3rd	$d_{3i}^2 = \sum_{k=1}^p l_k z_{ik}^2$	The significant PCs are already strongly reflected in the original variables themselves.
4th	$d_{4i} = \underset{p-q+1 \leq k \leq p}{\text{Max}} \left(\left \frac{z_{ik}}{\sqrt{l_k}} \right \right)$	Sharp and unexpected excursion of PC is caused by adding it to all the other insignificant PCs.

Variable Reduction Using PCA

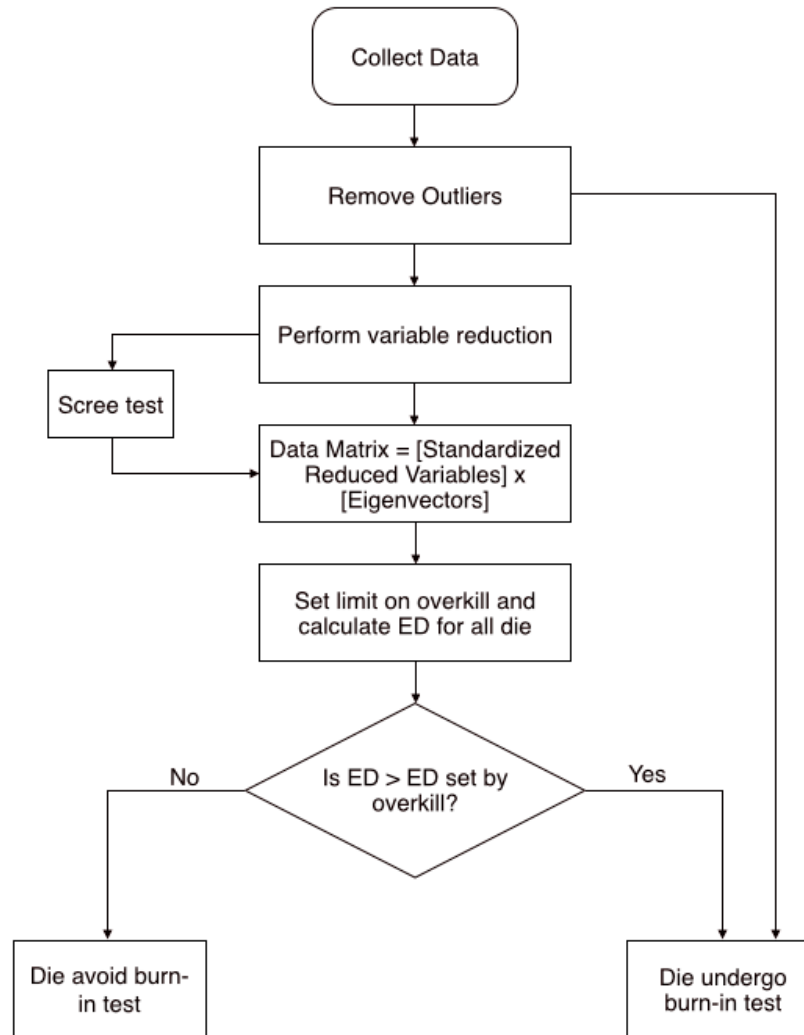


Classification

$$ED = \left(\sum (X_i - \bar{X}_i)^2 \right)^{1/2}$$



An Application Case: Burn-in Reduction



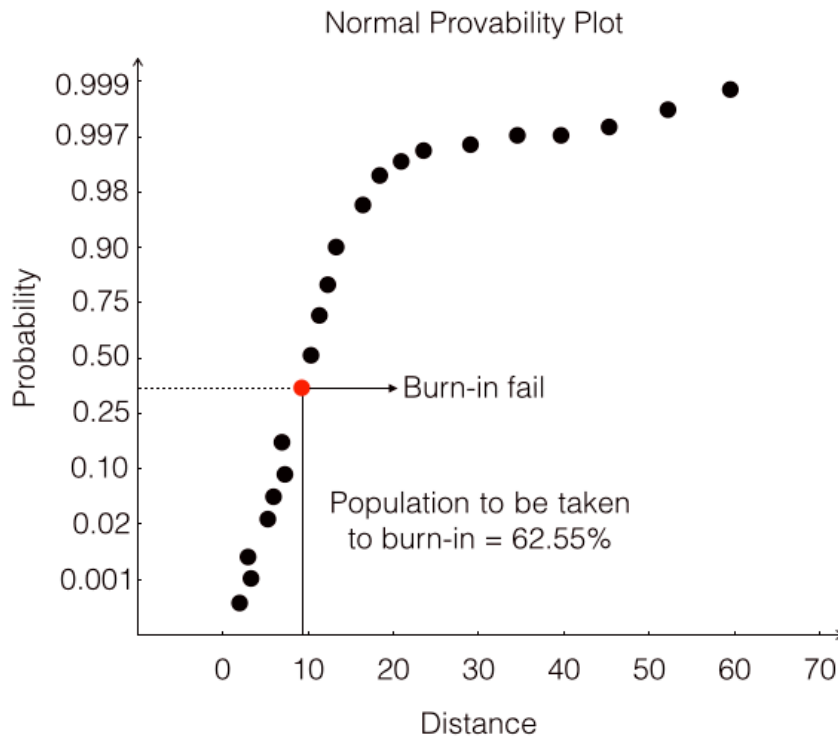
Experimental Analysis Basing on Burn-in Test

Contribution 1: Dimensionality Reduction

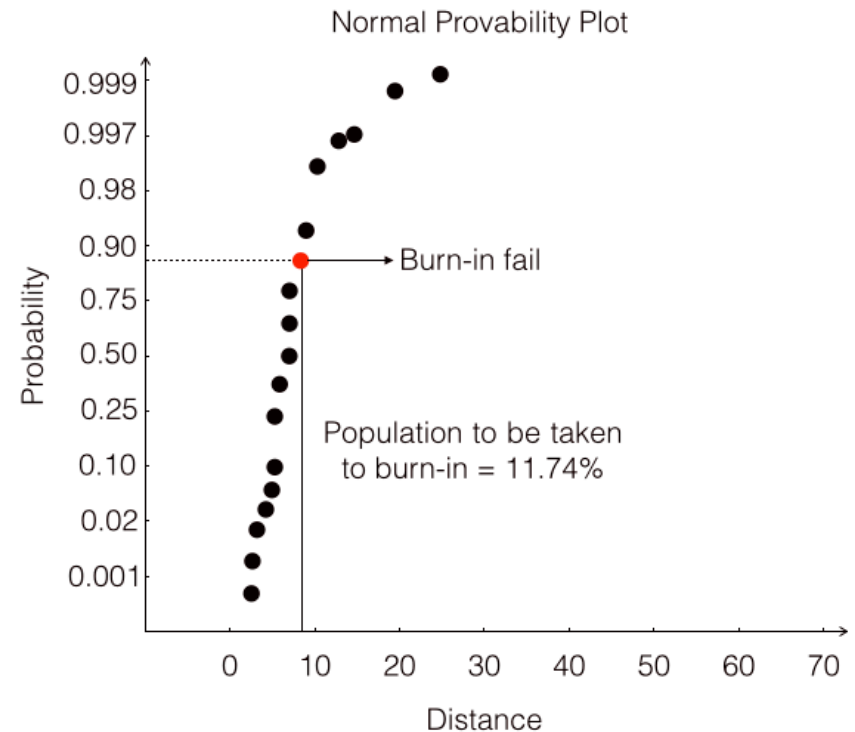
	No. of variables retained				Variance retained (%)			
Wafer no. Iteration no.	1	2	3	4	1	2	3	4
1	60	62	61	64	96	95	95	95
...
6	27	25	24	23	81	79	79	78

Experimental Analysis Basing on Burn-in Test

Contribution 2: Cost & Time Saving for Test



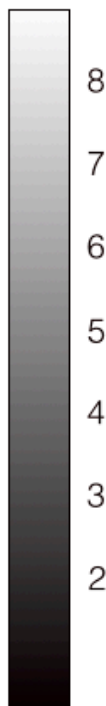
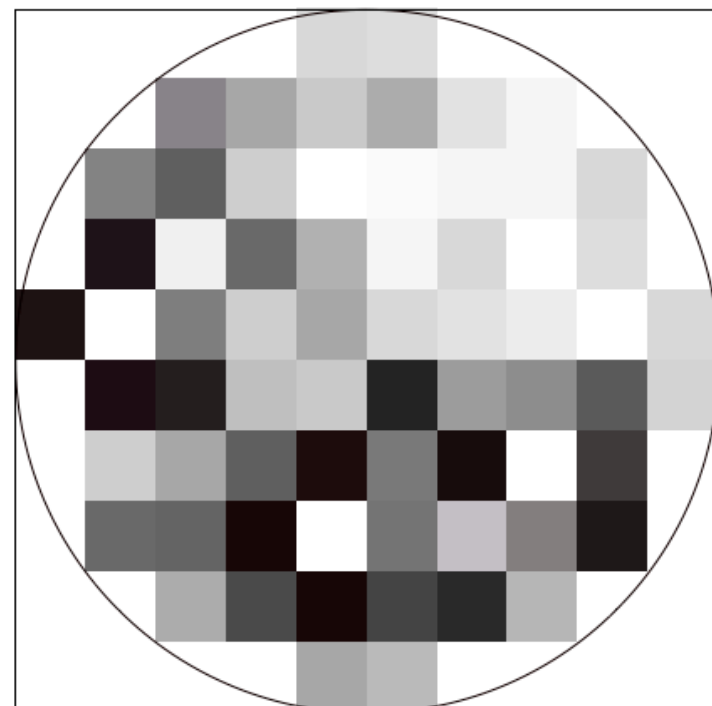
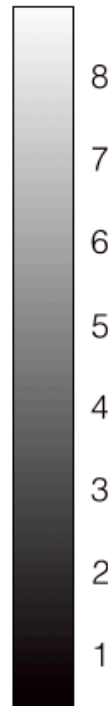
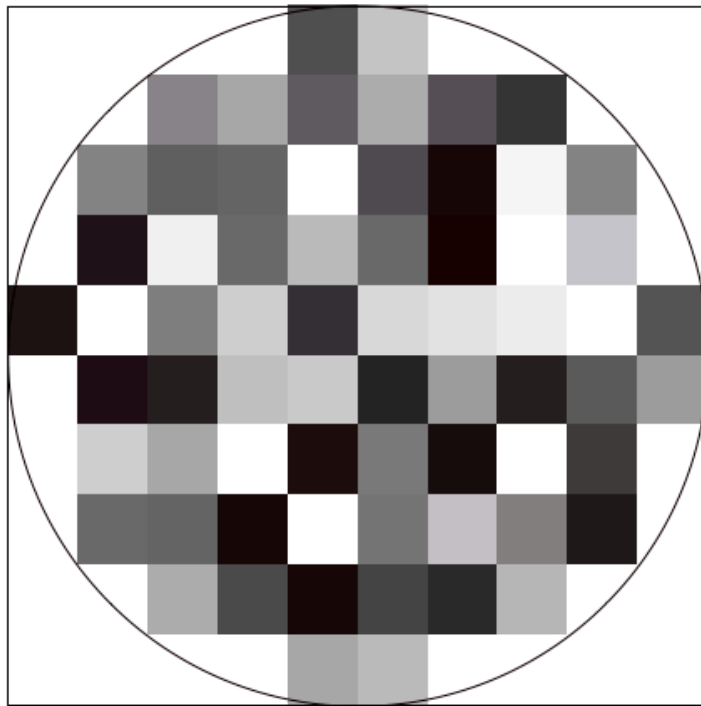
CDF of ED for single wafer before VR



CDF of ED for single wafer after VR

Experimental Analysis Basing on Burn-in Test

Contribution 3: Identifying Process Problems



CONCLUSIONS

Contributions:

- **Reduce the dimensionality of the test dataset**
- **Reduce the number of dies undergoing costly and time-consuming test, thereby saving test expense**

Further Improvement:

- **Better methods for outlier removing**
- **Better threshold setting method for variable reduction**
- **Better classification approaches**